

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

## PATENT WITHDRAWAL NOTICE

DATE WITHDRAWN	WITHDRAWAL NUMBER
8/22/08	16550
<p>The following application has been <b>WITHDRAWN</b> from the <b><u>Tuesday, September 02, 2008</u></b> issue.</p>	
SERIAL NO.	PATENT NUMBER
10/787,120	7,419,889
DRAWINGS	CLASS
019	438/487
TITLE	
LASER IRRADIATION METHOD, LASER IRRADIATION APPARATUS, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	
NAME AND ADDRESS	
KOICHIRO TANAKA, ET AL ATSUGI-SHI, JPX	
REASON FOR WITHDRAWAL	
Office of Petitions granted applicant's request to withdraw patent from issue.	
APPROVED	
/Kimberly Terrell/, Manager Patent Publication Branch Office of Data Management	